

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Eric BORNSTEIN  
Title: NEAR INFRARED MICROBIAL  
ELIMINATION LASER  
SYSTEM  
Appl. No.: 10/776106  
Filing Date: 2/11/2004  
Examiner: David M. Shay  
Art Unit: 3735  
Confirmation Number: 2676

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated July 11, 2008, concerning the above-referenced patent application.

Applicant has enclosed with this amendment a Petition for Extension of Time to make this response timely.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 5 of this document.

Please amend the application as follows: